

Hsue & De Runtz LLP

JUL 12 2004

07/14/04

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94111

655 Montgomery Street, Suite 1800 San Francisco, Ca 94111
tel 415.318.1160 fax 415.693.0194

July 12, 2004

Mail Stop Petitions
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant(s): Wayne G. Renken

Title: Process Condition Sensing Wafer and Data Analysis System

Application No.: 10/056,906 Filing Date: January 24, 2002

Examiner: Charles D. Garber Group Art Unit: 2856

Docket No.: SENS.005US0 Conf. No.: 2359

Dear Sir:

Transmitted herewith are the following documents in the above-identified application, hand delivered to the Office of Petitions:

- (1) Return receipt postcard;
- (2) This Transmittal Letter (in duplicate)
- (3) Request for Continued Examination (RCE) (1 page);
- (4) Information Disclosure Statement (2 pages);
- (5) PTO Form 1449 (1 page);
- (6) 1 cited reference;
- (7) Copy of Transmittal Letter (2 pages);
- (8) Copy of Amendment (9 pages);
- (9) Copy of Petition for Extension of Time and check for \$55.00 (2 pages);
- (10) Copy of Check for \$172.00 (1 page);
- (11) Copy of Return Receipt Postcard (1 page);
- (12) PAIR printout (2 pages)
- (13) Petition for Extension of Time (1 page); and
- (14) Check for \$860.00.

Please make the following charges to Deposit Account 502664:

<input checked="" type="checkbox"/> Fee for Request for Continued Examination (RCE)	\$ 385.00
<input checked="" type="checkbox"/> Fee for Petition for Extension of Time (3-months)	\$ 475.00
	Total: \$ 860.00

Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.

Please charge any additional fees required and credit any overpayment to our Deposit Account No. 502664.

EXPRESS MAIL NO.:

EV437667836US

Respectfully submitted,

Peter Gallagher 7/12/04

Peter A. Gallagher
Reg. No.47,584

Date

655 Montgomery Street, Suite 1800 San Francisco, CA 94111
 tel 415.318.1160 fax 415.693.0194



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May 12, 2004

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Commissioner For Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Applicant(s): Wayne G. Renken

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Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 12, 2004.

Franklin Dyer

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (in duplicate);
- (3) Amendment (9 pages)
- (4) Petition for Extension of Time (1 page)
- (5) Check for \$55.00;
- (6) Check for \$172.00 ;



No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED

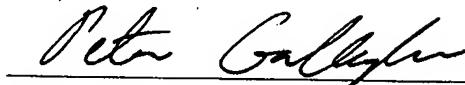
	Claims Remaining <u>After Amendment</u>		Highest No. Previously Paid For		Present <u>Extra</u>	Rate		Additional Fee
Total Claims	33	Minus	45	=	0	x \$9.00	\$	0.00
Independent Claims	8	Minus	4	=	4	x \$43.00	\$	172.00

<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application	\$
<input checked="" type="checkbox"/>	Fee for Petition for Extension of Time	\$ 55.00
	<u>Total additional fee for this Amendment:</u>	\$ 227.00
<input type="checkbox"/>	Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.	

Please charge any additional fees required and credit any overpayment to our Deposit Account No. 502664.

Date: May 12, 2004

Respectfully submitted,



Peter A. Gallagher
Peter A. Gallagher
Reg. No.47,584

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
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Application Number:	10/056,906	Customer Number:	36257
Filing or 371(c) Date:	01-24-2002	Status:	Final Rejection Mailed
Application Type:	Utility	Status Date:	01-09-2004
Examiner Name:	GARBER, CHARLES D	Location:	TECH CENTER 2800 EXAMINER OF REC
Group Art Unit:	2856	Location Date:	05-01-2004
Confirmation Number:	2359	Earliest Publication No:	US 2004-0031340 A1
Attorney Docket Number:	M-12467	Earliest Publication Date:	02-19-2004
Class/ Sub-Class:	073/866.1	Patent Number:	-
First Named Inventor:	Wayne Renken, San Jose, CA (US)	Issue Date of Patent:	-
Title Of Invention:	Process condition sensing wafer and data analysis system		

Select Search Option

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Search**File History**

Date	Contents Description
05-17-2004	Workflow incoming amendment IFW
01-12-2004	Mail Final Rejection (PTOL - 326)
01-09-2004	Final Rejection
11-14-2003	Information Disclosure Statement (IDS) Filed
11-12-2003	Petition Decision - Granted
01-21-2003	Rescind Nonpublication Request for Pre Grant Publication
01-21-2003	Rescind Nonpublication Request for Pre Grant Publication
10-23-2003	Date Forwarded to Examiner
10-16-2003	Response after Non-Final Action
10-16-2003	Request for Extension of Time - Granted
10-16-2003	Information Disclosure Statement (IDS) Filed
07-28-2003	Petition Entered
06-18-2003	Mail Non-Final Rejection
06-16-2003	Non-Final Rejection
05-31-2003	Date Forwarded to Examiner

05-13-2003	Response to Election / Restriction Filed
04-08-2003	Mail Restriction Requirement
04-07-2003	Requirement for Restriction / Election
07-08-2002	Information Disclosure Statement (IDS) Filed
07-08-2002	New or Additional Drawing Filed
10-28-2002	Case Docketed to Examiner in GAU
08-02-2002	Application Dispatched from OIPE
07-25-2002	Application Is Now Complete
07-08-2002	Additional Application Filing Fees
07-08-2002	A statement by one or more inventors satisfying the requirement under 115, Oath of the Applicant
07-08-2002	Applicant has submitted new drawings to correct Corrected Papers
03-14-2002	Notice Mailed--Application Incomplete--Filing Date Assigned
03-08-2002	IFW Scan & PACR Auto Security Review
02-07-2002	IFW Scan & PACR Auto Security Review
01-24-2002	Initial Exam Team nn

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Applicant(s): Wayne G. Renken

Title: Process Condition Sensing Wafer and Data Analysis System

Application No.: 10/056,906

Filing Date: January 24, 2002

JUL 20 2004

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Examiner: Charles D. Garber

Group Art Unit: 2856

Docket No.: SENS.005US0

Conf. No.: 2359

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant(s) respectfully petition(s) for a one-month extension of time within which to respond to the outstanding Response to Office Action of Nonprovisional Application, such extension allowing the undersigned until May 12, 2004 to respond.

A check is enclosed that includes the amount of \$55.00, as set forth in the enclosed transmittal letter.

Date: May 12, 2004

Respectfully submitted,

Peter A. Gallagher
Reg. No.47,584

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
(415) 318-1160 (main)
(415) 318-1167 (direct)
(415) 693-0194 (fax).

PARSONS HSUE & DE RUNTZ LLP

Invoice Date
05/12/2004

Invoice Number Check Notes
SENS.005US0 Acct#

003469
Amount
\$55.00

Check Amount: \$55.00

THE FACE OF THIS DOCUMENT IS BLUE - VOID WILL APPEAR WHEN COPIED

PARSONS HSUE & DE RUNTZ LLP

695 MONTGOMERY STREET, SUITE 1800
SAN FRANCISCO, CALIFORNIA 94111
(415) 318-1160

WELLS FARGO BANK, N.A.

CALIFORNIA
WWW.WELLSFARGO.COM

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DATE

05/12/2004

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Fifty five and 00/100 dollars

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TO THE ORDER OF Commissioner for Patents

2ND SIGNATURE REQUIRED ABOVE \$500

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PARSONS HSUE & DE RUNTZ LLP

*2000-001 \$55.00 SENS.005US0 PATENT: Extension of Time filing fee

Check Amount: \$55.00

PARSONS HSUE & DE RUNTZ LLP

Invoice Date
05/12/2004

Invoice Number Check Notes
SENS.005US0 Acct#

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Amount
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SAN FRANCISCO, CA 94111
(415) 318-1160

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P.O. BOX 1450
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